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03500.016133

PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
TADAYOSHI MUTA	)	Examiner: E. Lee
Application No.: 10/052,450	)	Group Art Unit: 2815
Filed: January 23, 2002	)	
For:	)	
SEMICONDUCTOR DEVICE,	)	
PRODUCTION METHOD	)	
THEREFOR, AND	)	
ELECTROPHOTOGRAPHIC	)	
APPARATUS	)	December 19, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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TECHNOLOGY CENTER 2800

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. A copy of each of the listed documents, together with an English-language abstract, is enclosed.

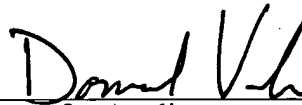
The listed documents were cited in a Search Report in a corresponding Chinese application. (The English-language version of the Search Report contains a typographical error. "JP2002-259803A" should read --JP2000-259803A--.) A copy of the Search Report, which is dated October 10, 2003, is enclosed. In view of this date, it is hereby certified under 37 C.F.R. §1.97(e) that each item of information in this Information Disclosure Statement was first cited in a communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing date of this Statement.

The Examiner is urged to study this information in its entirety and to form an independent determination of the materiality of the information to the claimed invention. Additionally, the Examiner is requested to indicate that this information has been considered by initialing the appropriate portion of the Form PTO-1449.

This application has received a final Office Action dated November 20, 2003. Accordingly, this Information Disclosure Statement is filed under 37 C.F.R. §1.97(d) and is accompanied by the \$180.00 fee specified at 37 C.F.R. §1.17(p). Consideration of the information cited herein is accordingly deemed proper, and such action is respectfully requested.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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